

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

: Tetsuo YAMADA, et al.

Serial No.

10/518,704

For

THIN FILM PIEZOELECTRIC RESONATOR, THIN

FILM PIEZOELECTRIC DEVICE, AND

MANUFACTURING METHOD THEREOF (As Amended)

Filing Date

December 17, 2004

Examiner

Tonya Lee

Group Art Unit

2834

Confirmation No.

5674

745 Fifth Avenue New York, NY 10151

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on September 20, 2006.

Ronald R. Santucci_Reg_No. 28,988

Assignee or Registered Representative

September 20, 2006

Date of Signature

RESPONSE TO RESTRICTION REQUIREMENT

Mail Stop Amendments Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

This is in response to the Office Action dated August 29, 2006, wherein restriction was required as follows:

Group I. Claims 1-45, drawn to a thin-film piezoelectric bulk acoustic wave device,

classified in class 310, subclass 334;

Group II. Claims 46 and 47, drawn to a method of manufacturing a piezoelectric

device, classified in class 29, subclass 25.35.

Applicant elects Group I (claims 1-45) for further prosecution in the present application.

The Commissioner is authorized to charge any additional fee that may be required to Deposit Account No. 50-0320.

Respectfully submitted,

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